

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Seung Woo Shin and Cha Deok Dong) I hereby certify that this paper and the documents referred to as enclosed therewith are being deposited with the
Serial No.: 10/631,362	United States Postal Service as first class mail, postage prepaid, on March 18, 2004, in an envelope addressed to Commissioner for Patents, P.O. Box 1450 Alexandria, Virginia 22313-1450
Filed: July 31, 2003	
For: Method of Forming Oxynitride Film) Alexandra, viiginia 22515-1450
Group Art Unit: 2812) Mickael K. Hull
Examiner: Alexander G. Ghyka) Reg. No. 35,902 Attorney for Applicants
)

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Please amend the above-identified patent application as follows:

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims begin on page 7 of this paper.

Remarks/Arguments begin on page 9 of this paper.